

JUL 16 2009

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Noboru Ichinose, et al.

Serial No.: 10/567,369

Group Art Unit: 2814

Filed: May 15, 2006

Examiner: Salerno, Sarah Kate

For: SEMICONDUCTOR LAYER WITH A Ga_2O_3 SYSTEM

Honorable Commissioner of Patents
Alexandria, VA 22313 – 1450
BOX AF

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the Office Action dated March 17, 2009, please Amend the above-identified application as follows:

INTRODUCTORY COMMENTS

Claims 1, 2, 4-21 are all the claims presently pending in the application. Claims begin on page 2 of this paper. No new matter is added.

Remarks begin at page 5 of this paper.

Exhibit 1 on page 13 of this paper is described on page 9.